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Bib Data Sheet

CONFIRMATION NO. 2896

| | | | | |
|-----------------------------|---------------------------------------|--------------|------------------------|---|
| SERIAL NUMBER 09/767,659 | FILING DATE 01/22/2001 RULE | CLASS 414 | GROUP ART UNIT 3652 | ATTORNEY DOCKET NO. A-67736-1/AJT/MSS |
|-----------------------------|---------------------------------------|--------------|------------------------|---|

APPLICANTS

Richard N. Savage, Scotts Valley, CA;

Frank S. Menagh, Santa Cruz, CA;
Helder R. Carvalheria, Scotts Valley, CA; Philip A. Troiani, Santa Cruz, CA;
Dan L. Cossentine, Santa Cruz, CA;
Eric R. Vaughan, Santa Cruz, CA;
Bruce E. Mayer, Soquel, CA;

**** CONTINUING DATA *******

This application is a DIV of 09/483,945 01/13/2000 PAT 6,610,150
and claims benefit of 60/127,532 04/02/1999
and claims benefit of 60/127,650 04/02/1999

**** FOREIGN APPLICATIONS *******

IF REQUIRED, FOREIGN FILING LICENSE GRANTED
**** 04/23/2001**

| | | | | |
|---|---------------------------|-------------------------|----------------------|----------------------------|
| Foreign Priority claimed <input type="checkbox"/> yes <input type="checkbox"/> no | STATE OR COUNTRY CA | SHEETS DRAWING 16 | TOTAL CLAIMS 6 | INDEPENDENT CLAIMS 2 |
| 35 USC 119 (a-d) conditions met <input type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | | | | |
| Verified and Acknowledged | Examiner's Signature | Initials | | |

ADDRESS
Maria S. Swiatek
FLEHR HOHBACH TEST ALBRITTON & HERBERT LLP
Four Embarcadero Center, Suite 3400
San Francisco , CA
94111-4187

TITLE
Semiconductor wafer processing system with vertically-stacked process chambers and single-axis dual-wafer transfer system

☐ All Fees



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UNITED STATES DEPARTMENT OF COMMERCE
United States Patent and Trademark Office
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No. _____ to charge/credit DEPOSIT ACCOUNT
No. _____ for following:

☐ All Fees☐ 1.16 Fees (Filing)☐ 1.17 Fees (Processing Ext. of
time)



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GRANTED ** 04/23/2001

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710

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| <input type="checkbox"/> All Fees |
| <input type="checkbox"/> 1.16 Fees (Filing) |
| <input type="checkbox"/> 1.17 Fees (Processing Ext. of time) |
| <input type="checkbox"/> 1.18 Fees (Issue) |
| <input type="checkbox"/> Other _____ |
| <input type="checkbox"/> |